## AMENDMENT UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE GROUP 2818 PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No: O83944

In re application of

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Hiroto OHTAKE, et al.	
Appln. No.: 10/509,898	Group Art Unit: 2818
Confirmation No.: 2975	Examiner: Hoang Quan Tran HO
Filed: October 1, 2004	
For: SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD	
AMENDMENT UNDER 37 C.F.R. § 1.116	
MAIL STOP AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	
Sir:	
In response to the Office Action dated October 3, 2006, please amend the above-	
identified application as follows on the accompanying pages.	
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